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PTO/SB/08A(08/00)

Approved for use through 10/31/2002, OMB 0651-0031

## INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

Application Number

Filing Date

12/12/2001

**First Named Inventor**

Muffoletto et al.

### Group Art Unit

1741

**Examiner Name**

## A Motion

Attorney Docket Number

04645.1002

Sheet

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of

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## U.S. PATENT DOCUMENTS

[illegible]

## FOREIGN PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS							
Examiner Initials*	Cite No. 1	Foreign Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear	T6
		Office3	Number4 (if known) Kind Code5				
ajm	9	WO 95/05499		Imperial Chemical Industries	02/23/1995		
	10	EP 0 878 857 A1		Katayama Special Industries Ltd.	11/18/1998		
	11	0 582 844 A1			07/12/1993		
ajm	12	0 446 584 A1		General Electric Company	09/18/1991		

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9/03

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		Filing Date	12/12/2001		
		First Named Inventor	Muffoletto et al.		
		Group Art Unit	1745		
		Examiner Name	A. Murata		
Sheet	4	of	4	Attorney Docket Number	04645.1002

## OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. 1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate, title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T2
gm	13	Thin Film Technology - Chapter 5 - Chemical Methods of Film Formation, pages 255-287	
	14	D.R. ROLISON, K. KUO, M. UMANA, D. BRUNDAGE, AND ROYCE W. MURRAY, Properties of RuOx Working Electrodes in Nonaqueous Solvents, Kenan Laboratories of Chemistry, University of North Carolina, Chapel Hill, North Carolina.	
	15	JOHN M. BLOCHER, JR., Vapor-Deposited Materials, edited by Carroll F. Powell, Joseph H. Oxley, John M. Blocher, JR., Battelle Memorial Institute, Columbus, Ohio, sponsored by The Electrochemical Society, Inc., New York, New York.	
	16	L.L. CHANG, L. ESAKI, W.E. HOWARD, R. LUDEKE, AND G. SCHUL, Structures Grown by Molecular Beam Epitaxy, IBM Thomas J. Watson Research Center, Yorktown Heights, New York.	
	17	P. BIRK and W. WEPFNER, Electrochemical analysis of thin film electrolytes and electrodes for application in rechargeable all solid state lithium microbatteries, Chair for Sensor and Solid State Ionics, Christian-Albrechts-University, Kaiserstr. 2, D-24143 Kiel, Germany	
	18	T. BROUSSE, R. MARCHAND, O RAYMOND, P FRAGNAUD, L. HEIDER and D.M. SCHLEICH, Preparation Of All-Oxide Lithium Ion Microbatteries, ISITEM, Laboratoire de genie des Materiaux, rue Christian Pauc, BP, T. H. Darmstadt, Thin Film Section, Material Science Dept. Petersen Str. 23, Darmstadt, Germany.	
	19	Patent Abstracts of Japan, 11017126, SHARP CORP., Deposition Of Ferroelectric Film and Ferroelectric Capacitor Element.	
gm	20	Patent Abstracts of Japan, 09235118, MURATA MFG CO LTD, Titanium Oxide Film	

Examiner Signature	<i>Chad J. K...</i>	Date Considered	9-3
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